

**IN THE UNITED STATES PATENT AND TRADEMARK OFFICE**

Applicant: TOMINAGA KOJI ET AL. . )  
Serial No.: 10/550,805 ) Group Art Unit: 2813  
Filed: July 12, 2006 ) Examiner: Luke, Daniel M.  
For: METHOD FOR FORMING AN ) Confirmation No. 3990  
INSULATING FILM IN A )  
SEMICONDUCTOR DEVICE )

**VIA EFS**  
Commissioner for Patents  
P.O. Box 1450  
Alexandria, VA 22313-1450

**REQUEST FOR RECONSIDERATION**

Sir:

This Request for Reconsideration is respectfully submitted in response to the Office Action dated October 17, 2008. Applicants hereby respectfully petition for a two-month extension of time. If there are any charges with respect to this Request for Reconsideration or otherwise, please charge them to Deposit Account No. 06-1130 maintained by Applicants' attorneys.